

Claim 11

11. A method for materials processing by means of plasma-inducing high-energy radiation, including laser radiation, in which instantaneous intensity of the radiation is measured at plural locations of a vapor capillary, characterized in that shapes of two spaced-apart peak-intensity regions (10, 12) of the radiation emitted from the vapor capillary, and of a minimum region (11) that is formed between the two peak-intensity regions of extreme values are detected metrologically, metrologically detected shapes of the regions of extreme values are compared with predetermined region shapes, and control of the materials processing operation takes place as a function of deviations of the detected shapes from the predetermined region shapes.

Claim 12

12. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when the shape of the minimum region (11) deviates from a predetermined near-circular region shape.

Claim 13

13. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when there are sharp regional boundaries in the regions (10', 12') of transition from the shape of the minimum region (11) to the shapes of the peak regions (10, 12).

Claim 14

14. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when the shape of one of the three regions of extreme values deviates from a predetermined region shape.

Claim 15

15. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when the shape of a peak-intensity region (10) that is in a leading position, in a feed direction (14), with respect to a workpiece moving relative to the radiation and the shape of the trailing peak region (12) deviate from predetermined region shapes.

Claim 16

16. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when the deviation in shape exceeds either of a predetermined difference magnitude and a predetermined duration.

17. The method as recited in claim 11, characterized in that control of the materials processing operation takes place as a function of angular positions assumed by a straight line (13) passing through the peak-intensity regions (10, 12) relative to a feed direction (14) of a workpiece being processed and moving relative to the radiation.

18. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when sporadically occurring, intensely radiating light spots (22) are detected in a region of measurement that is metrologically detecting the shapes of the regions of extreme values.

19. The method as recited in claim 11, characterized in that control of the materials processing of workpieces of different thicknesses takes place when the minimum region (11) deforms the peak region (10, 12) that is in one of a leading and trailing position in a feed direction.

20. The method as recited in claim 11, characterized in that control of the materials processing operation takes place when two submaxima (15, 16) present on both sides of a joint path in a peak region (10) that is in a leading position in a feed direction deviate from a predetermined symmetry.

REMARKS

The new claims have eliminated multiple dependencies and have been modified to improve form for U.S. practice.

Respectfully submitted,



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Enclosures (amended pp. 2, 16)

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